

*IN THE UNITED STATES PATENT AND TRADEMARK OFFICE*

Applicant: Takeshi HIKATA  
Title: METHOD OF PRODUCING CARBON NANOSTRUCTURE  
Appl. No.: Unassigned  
International Filing Date: 05/19/2005  
371(c) Date: 09/06/2006  
Examiner: Unassigned  
Art Unit: Unassigned

PRELIMINARY AMENDMENT

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examination of the present Application, Applicant respectfully requests that the application be amended as follows:

**Amendments to the Abstract** are presented as a new Abstract attached to this document for insertion after the claim pages of the application (or to replace the previously submitted Abstract).

**Amendments to the Specification** begin on page 2 of this document.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this document.

**Remarks/Arguments** begin on page 6 of this document.

Please amend the application as follows: